Notice of Allowability	Application No.	Applicant(s)	<del>(`,</del> \
	10/050,599	HONG ET AL.	
	Examiner	Art Unit	T
	Kirsten C Jolley	1762	
The MAILING DATE of this communication appe All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RI of the Office or upon petition by the applicant. See 37 CFR 1.313	pars on the cover sheet wit (OR REMAINS) CLOSED in or other appropriate commu GHTS. This application is st	th the correspondence addition this application. If not include unjection will be mailed in due	ded
1. X This communication is responsive to after-final amendment	ts, arguments, and Declarati	ion of 11/15/04.	
2. X The allowed claim(s) is/are 1,2,5-7,9,12 and 15-18.			
3. A The drawings filed on 18 January 2002 are accepted by the	e Examiner.		
<ul> <li>4.  Acknowledgment is made of a claim for foreign priority un a)  All b)  Some* c)  None of the:</li> <li>1.  Certified copies of the priority documents have</li> <li>2.  Certified copies of the priority documents have</li> <li>3.  Copies of the certified copies of the priority documents have International Bureau (PCT Rule 17.2(a)).</li> <li>* Certified copies not received:</li> </ul>	been received. been received in Application	n No	ation from the
Applicant has THREE MONTHS FROM THE "MAILING DATE" of noted below. Failure to timely comply will result in ABANDONMETHIS THREE-MONTH PERIOD IS NOT EXTENDABLE.	of this communication to file a ENT of this application.	a reply complying with the red	quirements
<ol> <li>A SUBSTITUTE OATH OR DECLARATION must be submit INFORMAL PATENT APPLICATION (PTO-152) which give:</li> </ol>	tted. Note the attached EXAI s reason(s) why the oath or	MINER'S AMENDMENT or N declaration is deficient.	OTICE OF
6. ☐ CORRECTED DRAWINGS ( as "replacement sheets") must  (a) ☐ including changes required by the Notice of Draftsperso  1) ☐ hereto or 2) ☐ to Paper No./Mail Date  (b) ☐ including changes required by the attached Examiner's Paper No./Mail Date  Identifying indicia such as the application number (see 37 CFR 1.8 each sheet. Replacement sheet(s) should be labeled as such in the  7. ☐ DEPOSIT OF and/or INFORMATION about the depos attached Examiner's comment regarding REQUIREMENT F	on's Patent Drawing Review  Amendment / Comment or i  84(c)) should be written on the e header according to 37 CFR	in the Office action of  e drawings in the front (not the the 1.121(d).  RIAL must be submitted to	
Attachment(s)			
1. Notice of References Cited (PTO-892)	5. Notice of Info	ormal Patent Application (PTC	D-152)
2. Notice of Draftperson's Patent Drawing Review (PTO-948)	6. Interview Sur	nmary (PTO-413),	
<ol> <li>Information Disclosure Statements (PTO-1449 or PTO/SB/08 Paper No./Mail Date</li> </ol>	3), 7. ☐ Examiner's A	fail Date mendment/Comment	
1. ☐ Examiner's Comment Regarding Requirement for Deposit		statement of Reasons for Allo	wance
of Biological Material	9. 🗌 Other		

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## REASONS FOR ALLOWANCE

1. The following is an examiner's statement of reasons for allowance:

The 35 USC 112, 1<sup>st</sup> paragraph rejection set forth in the final Office action has been withdrawn in response to the amendment to claim 15.

The Declaration submitted under 37 CFR 1.132 on November 15, 2004 has been considered, and is sufficient the overcome the 35 USC 102(a) rejections over the article by Cho et al. set forth in section 7 of the prior Office action, for the reasons argued by Applicant and set forth in MPEP 715.01(c) and 716.10.

The 35 USC 103(a) rejections over Decher et al. in view of Chabrecek et al. alone, or over Decher et al. in view of Chabrecek et al. and Ushijima, have been withdrawn in response to Applicant's showing of unexpected results as discussed in the final Office action. The showing is considered commensurate in scope with the claims in response to Applicant's amendments to independent claim 1, as well as in response to Applicant's arguments stating that materials other than polyelectrolytes were used in fabricating the film of the present invention (as demonstrated in the table on pages 7-8 of Applicant's after-final response), and Applicant's arguments stating that the particular spinning time is dependent upon the time for removing the particular solvent used in the coating and washing steps and is influenced by the choice of solvent, spinning speed, and the like.

The 35 USC 103(a) rejections over the publication to Dubas et al. have been withdrawn in response to Applicant's arguments that the Dubas et al. method is a hydrodynamic method in which the substrate on a rotating shaft is dipped into beakers of the layer producing material and

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solvent, and rotation occurs while immersing. Applicant argues that the results achieved by the present invention will not be achieved during the dip cycling method of Dubas et al. because the improved multilayers of the present invention are formed not only by the attractive intermolecular force between adjacent layers, but also by the viscous force due to facile solvent removal during spinning, and other factors encountered during spinning such as shear air force (as argued in the second full paragraph on page 10 of the after-final response). Such solvent removal (and the forces generated therefrom), as well as shear air force, would not occur in the process of Dubas et al. since Dubas et al.'s spinning occurs while the substrate is still immersed in solution. (This is further evidenced by Dubas et al.'s statement that the trends in film thickness on its rotating substrates are similar to those for static dip-cycled multilayers.) Thus Applicant's arguments are convincing, and it is the Examiner's position that similar unexpected results would be achieved when comparing the claimed spinning process of the instant invention to the hydrodynamic dipping process of Dubas et al. as those achieved in comparing the claimed spinning process to a conventional dipping process (as discussed in the specification).

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

2. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Kirsten C Jolley whose telephone number is 571-272-1421. The examiner can normally be reached on Monday to Thursday and every other Friday.

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If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Shrive P Beck can be reached on 571-272-1415. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Kirsten C Jolley Primary Examiner

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